

Paper No.: _____

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Inventor(s): CHAPMAN, Glenn H.; SARUNIC, Marinko Venci; TU, Yugiang
Title: **DRY MULTILAYER INORGANIC ALLOY THERMAL RESIST FOR
LITHOGRAPHIC PROCESSING AND IMAGE CREATION**
Serial No.: Unassigned
Filed: Herewith
Date: 17 October 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

**LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION DISCLOSURE STATEMENT**
[Form PTO-1449 (Modified)]

United States Patent Documents

Examiner	ID	Patent No.	Issue Date	Inventor(s)	Class	Sub-Cl	Filing Date
SPM	US: 1	4,211,838	8 July 1980	Izu et al.	—	—	
SPM	US: 2	4,082,861	4 April 1978	Izu et al.	—	—	
SPM	US: 3	4,587,533	6 May 1986	Nakane et al.	—	—	
SPM	US: 4	5,851,729	22 Dec. 1998	Takeuchi et al.	—	—	
SPM	US: 5	5,998,066	7 Dec. 1999	Block et al.	—	—	
SPM	US: 6	3,873,341	25 Mar. 1975	Alan R. Janus	—	—	
SPM	US: 7	4,619,894	28 Oct. 1998	Carl O. Bozler	—	—	

Other Art

Examiner	ID	Author, Title, Date, Pertinent Pages, etc.
SRM	OA: 1	Gelbart and Karasyuk, Proc. SPIE Emerging Lithographic Technologies III, V 3676, pg 786-793 (1999)
	OA: 2	

Examiner: Mohamedolla

Date Considered: 11/29/04

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance **and** not considered. Include copy of this form with next communication to applicant.